

30. (Three times amended) A sensor for detecting an amount of a gas, comprising

an oxygen-ion conductive solid electrolyte substrate having a flat side, a negative electrode and a positive electrode formed on the same flat side of the substrate so as to pump oxygen from the negative electrode to the positive electrode, and a gas diffusion limiting means for limiting the gas diffusing into the negative electrode,

wherein the ratio of the area of said negative electrode to the area of said positive electrode is set within a range of 2:1 to 5:1, and

said sensor comprising a circuit for applying an electric potential between said negative and positive electrodes such that a pump current flows between the negative and positive electrodes when the sensor is used for detecting the amount of a gas, said pump current being a measurement of the amount of gas.

31. (Three times amended) A sensor for detecting an amount of a gas, comprising

an oxygen-ion conductive solid electrolyte substrate having a flat side, a negative electrode and a positive electrode formed on the same flat side of the substrate so as to pump oxygen from the negative electrode to the positive electrode, and a gas diffusion limiting means for limiting the gas diffusing into the negative electrode,

wherein the ratio of the area of said negative electrode to the area of said positive electrode is set within a range of 1:2 to 1:5, and

said sensor comprising a circuit for applying an electric potential between said negative and positive electrodes such that a pump current flows between the negative and positive electrodes when the sensor is used to detect the amount of a gas, said pump current being a measurement of the amount of gas.

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32. (Twice amended) An oxygen sensor for determining the oxygen concentration of a gas, comprising first and second chambers (62, 64) formed between first and second oxygen ion conductive cell substrates (66, 68) and first and second electrodes (68a, 68b) formed on the same plane of the second cell substrate (68), said first electrode (68a) being formed on an inside wall of the second chamber (64) and said second electrode (68b) being formed outside of the second chamber (64),

wherein the area of the first electrode is at least twofold larger than that of the second electrode, and

the sensor comprises means for applying an electric potential in the range of 0.2 V to 1.1 V between the first and second electrodes such that a pump current flows between the first and second electrodes when the sensor is used to determine the concentration of oxygen in a gas, said pump current being a measurement of oxygen concentration.

33. (Twice amended) A humidity sensor for determining the humidity of a gas, comprising first and second chambers (62, 64) formed between first and second oxygen ion conductive cell substrates (66, 68) and first and second electrodes (68a, 68b) formed on the same plane of the second cell substrate (68), said first electrode (68a) being formed on an inside wall

of the second chamber (64) and said second electrode (68b) being formed outside of the second chamber (64),

wherein the area of the first electrode is at least twofold larger than that of the second electrode, and

the sensor comprises means for applying an electric potential in the range of 1.1 V to 2.5 V between the second electrodes such that a pump current flows between the first and second electrodes when the sensor is used to determine the humidity of a gas, said pump current being a measurement of humidity.

34. (Twice amended) An oxygen sensor for determining the oxygen concentration as a component of a gas containing NO_x, comprising first and second chambers (62, 64) formed between first and second oxygen ion cell substrates (66, 68) and first and second electrodes (68a, 68b) formed on the same plane of the second cell substrate (68), said first electrode (68a) being formed on an inside wall of the second chamber (64) and said second electrode (68b) being outside of the second chamber (64),

wherein the area of the first electrode is at least twofold larger than that of the second electrode, and

the sensor comprises means for applying an electric potential in the range of 0.2 V to less than 0.5 V such that a pump current flows between the first and second electrodes when the sensor is used to determine oxygen concentration as a component of a gas containing NO_x, said pump current being a measurement of oxygen concentration.

AMENDMENT UNDER 37 C.F.R. § 1.116
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35. (Amended) The oxygen sensor as claimed in, claim 34 comprising a circuit for applying an electric potential in the range of 0.2 V to less than 0.5 V such that a pump current of less than 10 microamperes flows between the first and second electrodes when the sensor is used to determine oxygen concentration as a component of a gas containing NO_x, said pump current being a measurement of oxygen concentration.
